

PATENT

**Expedited Procedure
Under 37 C.F.R. § 1.116
Technology Center 2800**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Zhiping Yin

Serial No.: 10/715,227

Filed: November 17, 2003

For: SEMICONDUCTOR DEVICES AND
STRUCTURES INCLUDING
SUBSTANTIALLY DEFECT-FREE AND
CONTAMINANT-FREE ANTI-
REFLECTIVE COATINGS (as amended)

Confirmation No.: 5021

Examiner: M. Lewis

Group Art Unit: 2822

Attorney Docket No.: 2269-3657.5US
(98-0265.05/US)

**VIA ELECTRONIC FILING
January 21, 2008**

AMENDMENT UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Examiner:

This Amendment follows the final Office Action of November 20, 2007, the shortened statutory period for response to which expires on February 20, 2008. This Amendment is being submitted within two months of the mailing date of the final Office Action.

A listing of claims, in which amendments to the claims are presented, begins on page 2 of this paper; and

Remarks start at page 4 of this paper.